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APPLICANTS

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** CONTINUING DATA *****

** FOREIGN APPLICATIONS ***** *M*

JAPAN 2002-220027 07/29/2002

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 17	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 5
Verified and Acknowledged _____ Examiner's Signature	<i>P</i> Initials				

ADDRESS

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TITLE

Epitaxial wafer production apparatus and susceptor structure

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